

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Makoto NAGASHIMA

Confirmation No.: 2136

Serial No. 10/662,863

Group Art Unit: 1753

Filed: September 15, 2003

Examiner: Rodney G. MCDONALD

**FOR: APPARATUS FOR LOW TEMPERATURE SEMICONDUCTOR
FABRICATION**

MAIL STOP AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION OF SEPTEMBER 12, 2005

Sir:

In response to the final Office Action dated September 12, 2005, Applicant submits the following amendments and remarks:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.